

<b>Notice of References Cited</b>	Application/Control No. 10/660,920	Applicant(s)/Patent Under Reexamination ZHANG ET AL.	
	Examiner Edna Wong	Art Unit 1753	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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	B	US-6,848,975	02-2005	Duquette et al.	451/41
	C	US-2,868,705	01-1959	BAIER JOHN J; et. al.	205/680
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*	N	JP 11117100 A	04-1999	Japan	KIKUCHI et al.	C25F 03/16
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**NON-PATENT DOCUMENTS**

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*	U	Baumgaertner et al., "Characterization of Electropolishing Baths with Electrochemical Methods", Galvanotechnik, Vol. 86, No. 2 (no month, 1995), pp. 376-82.
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\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
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